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JUL 27 2006

Docket No. 740819-1041
Serial No. 10/759,180
Page 1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)
Takeshi Yamashita et al.) Group Art Unit: 1765
Serial No. 10/759,180) Examiner: Chen, Kin-Chan
Filed: January 20, 2004) Confirmation No. 7694
For: DRY ETCHING METHOD, FABRICATION) Date: July 27, 2006
METHOD FOR SEMICONDUCTOR DEVICE,
AND DRY ETCHING APPARATUS

CERTIFICATE OF MAILING OR TRANSMISSION
[37 CFR 1.8(a)]

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Signature: 

Name: Jeannie Sexton

AMENDMENT AFTER FINAL REJECTION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated, April 27, 2006, please amend the above identified application as follows.

O.K. to enter.
KCC 8/1/06